

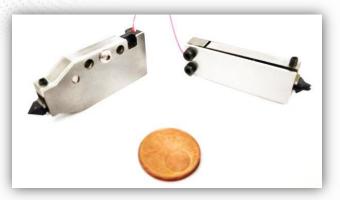


PRODUCTS





THE PIEZOELECTRIC GRIPPERS FOR MICRO MANIPULATION

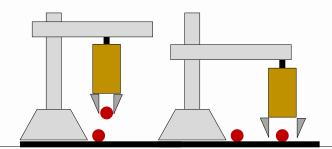




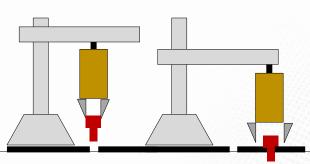
- ☐ Clamping force: up to 4 N
- ☐ Adjustable initial opening
- ☐ High dynamic range
- ☐ Customizable shape and performances
- ☐ Phi Drive's electronics available



MOUNTING CHAIN FOR MICRO COMPONENTS

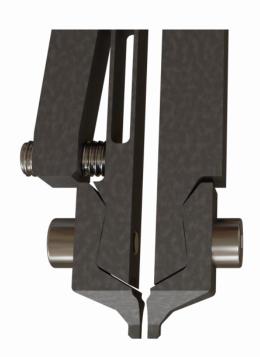


MANIPULATION OF MICRO COMPONENTS





THE PIEZOELECTRIC GRIPPERS FOR MICRO MANIPULATION



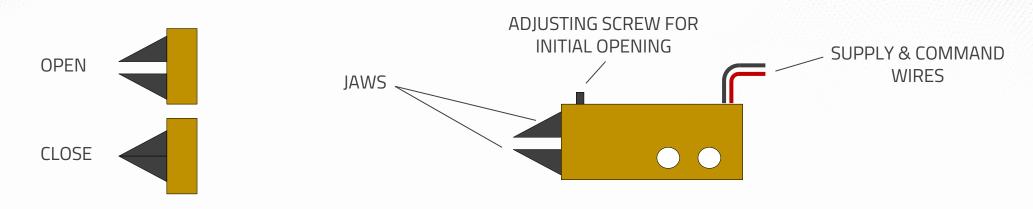


WIDE VARIETY OF JAWS TO CHOOSE FROM:

- ☐ Monolithic/interchangeable
- ☐ Normally-open/normally-closed
- ☐ Parallel/non-parallel
- ☐ Single-effect/double-effect



THE PIEZOELECTRIC GRIPPERS FOR MICRO MANIPULATION

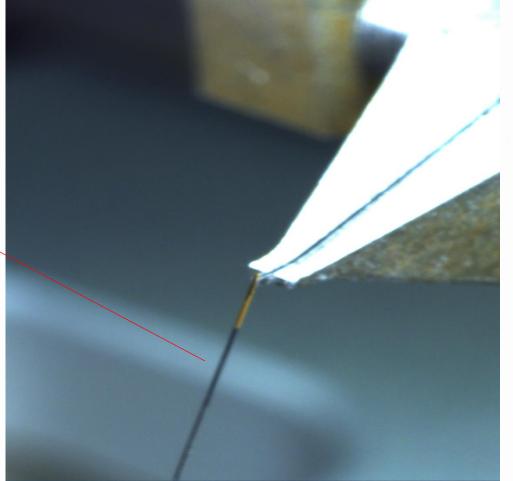


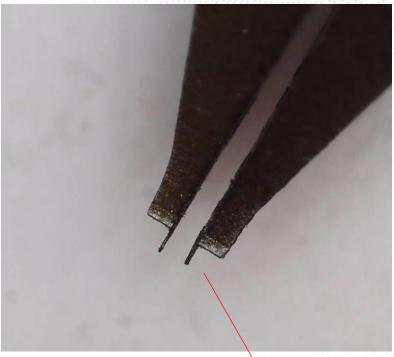
MODEL	STROKE	SAMPLE SIZE	GRIPPING FORCE @0.5 STROKE	GRIPPING TIME	BROCHURE
А	0.8 mm	.022 mm	2 N	<50 ms	<u>Datasheet</u>
В	0.7 mm	.2-1 mm	2 N	<50 ms	<u>Datasheet</u>
С	0.5 mm	1-3 mm	4 N	<50 ms	<u>Datasheet</u>



MAIN APPLICATIONS: MICROELECTRONICS ASSEMBLY, SILICON-BASED DEVICES TESTING

NEEDLE THICKNESS: 40 μm





JAW EDGES THICKNESS: 30 µm



GRIPHI DRIVER

DRIVER FOR PIEZOELECTRIC GRIPPERS







MAIN FEATURES

- ☐ Compatible with all GriPhi piezo grippers
- Expansion port
- ☐ USB PC interface
- 2 channels
- ☐ Standalone and Basic versions available
- ☐ PC software included

- ☐ Easy to use
- ☐ Programmable time diagrams
- API available for advanced users
- ☐ Compact device

OPTIONAL: E0018X MODULE TO CONNECT GRIPHI DRIVER TO A PLC



GRIPHI REC

STEPPER AND HYBRID (STEPPER + PIEZO) GRIPPERS FOR HIGH STROKES











- ☐ Gripper stroke: up 20 mm
- ☐ Clamping force: up to 235 N (stepper segment), 4 N (piezo segment)
- ☐ Adjustable initial opening
- ☐ High dynamic range
- ☐ Customizable shape and performances
- ☐ Phi Drive's electronics available



COR-RS

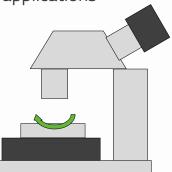
THE HIGH PRECISION ROTARY POSITIONER

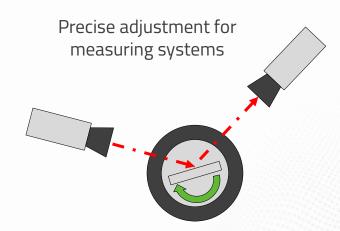


MAIN FEATURES

- □ +/-360° travel range
- ☐ High precision, no backlash, no friction and no lubricant
- ☐ Customizable shape and performances
- Nanometric resolution
- ☐ Custom electronics available

Moving table for precision optics applications

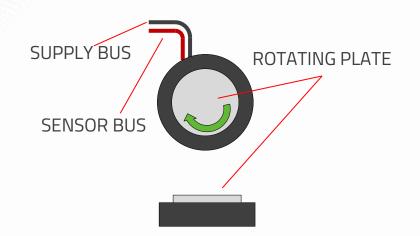




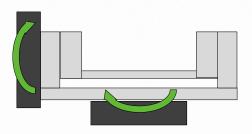


COR-RS

THE HIGH PRECISION ROTARY POSITIONER



COMBINABLE FOR MULTIPLE AXIS SYSTEMS

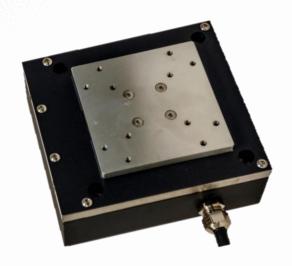


MODEL	MINIMUM STEP	STALL TORQUE	MAXIMUM LOAD	ANGULAR SPEED	BROCHURE
RS.SS.E0.2	200 μrad	0.30 Nm	5 kg	1.6 RPM	<u>Datasheet</u>
RS.SS.E0.1	60 µrad	0.28 Nm	5 kg	1.7 RPM	<u>Datasheet</u>

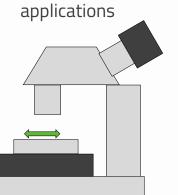


COR-PS

THE LINEAR NANO-POSITIONING PIEZO STAGE



Moving table for precision optics



MAIN FEATURES

- ☐ Resolution: 0.18 ÷ 15 nm
- Travel range: up to 160 μm
- ☐ Close loop available
- ☐ Electronics and PC GUI available

Precise adjustment for measuring systems

Laser marking systems





COR-PS

THE LINEAR NANO-POSITIONING PIEZO STAGE



MODEL	STROKE	RESOLUTION @OPEN LOOP	MAXIMUM LOAD	SETTLING TIME @UNLOADED	BROCHURE
COR.PS.SC	150 µm	0.2 nm	5 kg	0.1 ms	<u>Datasheet</u>
COR.PS.HC	135 µm	0.2 nm	5 kg	0.1 ms	<u>Datasheet</u>

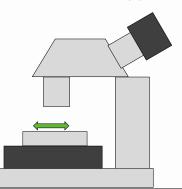


PHI-SS-LI

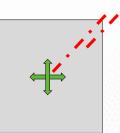
THE MICRO LINEAR POSITIONING PIEZO STAGE



Moving table for precision optics, EDM, machine tools applications



- Resolution: 0.05 μm
- ☐ Travel range: 10 mm
- ☐ Close loop available
- ☐ Electronics and PC GUI available
- Precise adjustment for measuring systems
- Laser marking systems





PHI-SS-LI

THE MICRO LINEAR POSITIONING PIEZO STAGE



MODEL	STROKE	RESOLUTION @OPEN LOOP	MAXIMUM LOAD	SETTLING TIME @UNLOADED	BROCHURE
COR.PS.LS.A10	10 mm (STD) 50 mm (CUSTOM)	0.05 μm	500 g (V RAIL) 2500 g (S RAIL)	0.1 ms	<u>Datasheet</u>

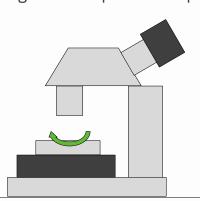


PHI-SS-MI

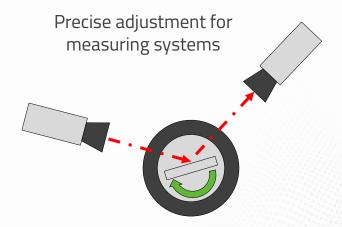
THE MICRO PIEZOELECTRIC PRECISION ROTARY POSITIONER



Moving table for precision optics



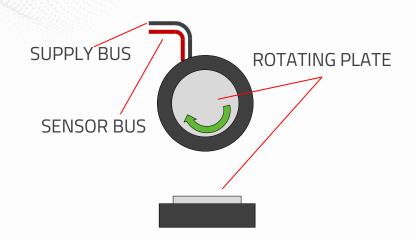
- \Box +/-360° travel range
- ☐ High precision, no backlash, no friction and no lubricant
- ☐ Customizable shape and performances
- Nanometric resolution
- ☐ Compatible with PHI-SS driver





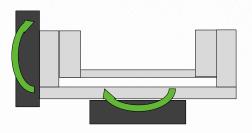
PHI-SS-MI

THE MICRO PIEZOELECTRIC PRECISION ROTARY POSITIONER





COMBINABLE FOR MULTIPLE AXIS SYSTEMS



MODEL	MINIMUM STEP	MAXIMUM LOAD	ENCUMBRANCE: MIMINUM DIAMETER	ANGULAR SPEED	BROCHURE
M.SS	500 nrad	0.5 kg	22 mm	8 RPM	<u>Datasheet</u>



PHI-SS-ME

INTERMEDIATE SIZE PRECISION ROTARY POSITIONER



PHI DRIVE'S SMALLEST SOLUTION WITH ON-BOARD ENCODER!

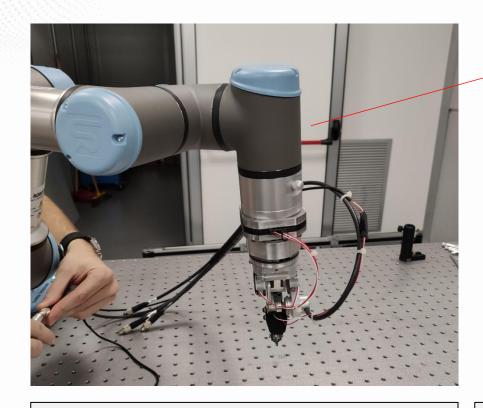
- □ +/-360° travel range
- ☐ High precision, no backlash, no friction and no lubricant
- ☐ Customizable shape and performances
- ☐ Accuracy of 1 mrad
- ☐ Closed-loop control
- ☐ Compatible with PHI-SS driver





ROBOT WRIST – MULTIPLE PIEZOELECTRIC DEVICE

MAIN APPLICATIONS: OPTICS, LASER SYSTEMS, PRECISE MANIPULATORS



MOUNTED ON A COMMERCIAL COBOT (UR3E BY UNIVERSAL ROBOTS)

TILTING STAGE (±5°) A.K.A. PHI-SS-GP

X-Y CALIBRATION SYSTEMS

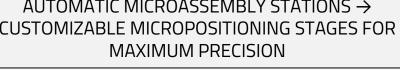
PHI-SS-ME

AUTOMATIC MICROASSEMBLY STATIONS → CUSTOMIZABLE MICROPOSITIONING STAGES FOR MAXIMUM PRECISION

ANGULAR CORRECTION **RESOLUTIONS DOWN TO 0.5** μRAD



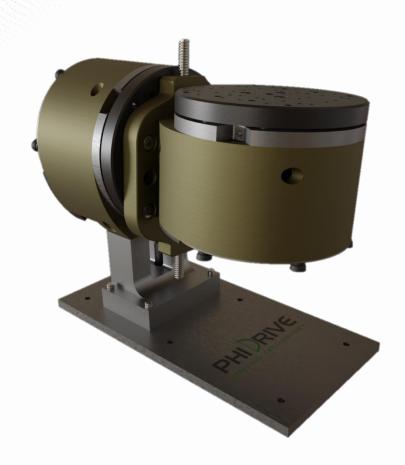
Z CALIBRATION SYSTEM





PHI-SS-MA

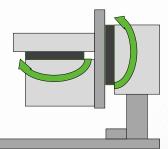
HIGHLY-PERFORMING PRECISION ROTARY POSITIONER



MAIN FEATURES

- ☐ Available with 2 degrees of freedom
- ☐ High precision, no backlash, no friction and no lubricant
- ☐ Customizable shape and performance
- ☐ Extremely high resolution
- ☐ High achievable torque
- ☐ Closed-loop control

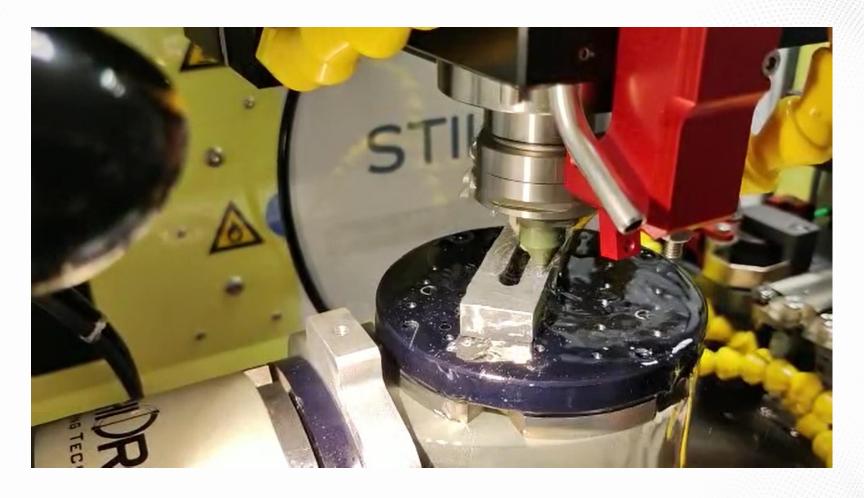
Moving table for Electrical Discharge Machining





PHI-SS-MA

MAIN APPLICATIONS: EDM (ELECTRICAL DISCHARGE MACHINING)





PHI-SS

DRIVER FOR ROTARY AND LINEAR TABLES



- ☐ Compatible with PHI-SS-MI
- ☐ Compatible with PHI-SS-ME
- ☐ Compatible with PHI-SS-MA
- ☐ Compatible with PHI-SS-LI
- ☐ USB PC interface
- ☐ Encoder data acquisition
- PC software included
- ☐ Elegant design
- Driver and ampli versions







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